

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

| APPLICATION NO. | FILING DATE | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO. | CONFIRMATION NO. | |
|-----------------|--|------------------------|---------------------|------------------|--|
| 10/616,863 | 07/10/2003 | Francesco Cerrina | 7151 | 1476 | |
| 22922 | 7590 06/30/2005 | | EXAMINER | | |
| | T BOERNER VAN DEUI | MOHAMEDULLA, SALEHA R | | | |
| | DA GABRIEL, DOCKET C H WATER STREET | ART UNIT | PAPER NUMBER | | |
| SUITE 2100 | | 1756 | | | |
| MILWAUK | EE, WI 53202 | DATE MAILED: 06/30/200 | 5 | | |

Please find below and/or attached an Office communication concerning this application or proceeding.

| | | لمم | | | |
|---|--|--|--|---|---------------------|
| | | Applica | ation No. | Applicant(s) | |
| Office Action Summan | | 10/616 | ,863 | CERRINA ET AL. | |
| Office | Action Summary | Examir | er | Art Unit | _ |
| | | | R. Mohamedulla | 1756 | |
| The MAIL Period for Reply | ING DATE of this communi | cation appears on | the cover sheet w | ith the correspondence ac | ldress |
| THE MAILING D - Extensions of time mafter SIX (6) MONTH - If the period for reply - If NO period for reply - Failure to reply within Any reply received by | STATUTORY PERIOD FO ATE OF THIS COMMUNIO ay be available under the provisions of S from the mailing date of this common specified above is less than thirty (30 is specified above, the maximum state of the set or extended period for reply of the Office later than three months aff djustment. See 37 CFR 1.704(b). | CATION. f 37 CFR 1.136(a). In no nication. days, a reply within the sutory period will apply and rill, by statute, cause the a | event, however, may a tatutory minimum of thin I will expire SIX (6) MON application to become Al | reply be timely filed ty (30) days will be considered timel NTHS from the mailing date of this c BANDONED (35 U.S.C. § 133). | y. ommunication. |
| Status | | | | | |
| 2a)☐ This action 3)☐ Since this | e to communication(s) filed is FINAL. 2 application is in condition factoring the condition for the condition of the condition factoring the condition | b)⊠ This action is or allowance exce | pt for formal mat | | e merits is |
| Disposition of Clair | ns | | | | |
| 4a) Of the a 5)⊠ Claim(s) <u>1</u> 6)⊠ Claim(s) <u>1</u> 7)⊠ Claim(s) <u>3</u> | 23 is/are pending in the apabove claim(s) is/ard 1-15,22 and 23 is/are allow 2,6-10 and 16-19 is/are re 5 and 20-21 is/are objecte are subject to restrict | e withdrawn from ored. ected. d to. | | | |
| Application Papers | | | | | |
| 10)∭ The drawing Applicant m Replacemer | cation is objected to by the g(s) filed on is/are: ay not request that any object that drawing sheet(s) including the graphs. | a) ☐ accepted or ion to the drawing(s he correction is requ |) be held in abeyar uired if the drawing | nce. See 37 CFR 1.85(a). (s) is objected to. See 37 CF | |
| 11)[_] The oath or | declaration is objected to | by the Examiner. | Note the attached | d Office Action or form PT | O-152. |
| Priority under 35 U. | S.C. § 119 | | | | |
| a) □ All b) □ 1. □ Certi 2. □ Certi 3. □ Copi appli | gment is made of a claim for a claim for a claim for a claim for a come and a claim for a come and a claim for a come and a claim for a cl | ocuments have be ocuments have be the priority docur al Bureau (PCT R | een received. een received in A nents have been ule 17.2(a)). | application No received in this National | Stage |
| Attachment(s) | | | | | |
| 3) 🔯 Information Disclosu | on's Patent Drawing Review (PT ure Statement(s) (PTO-1449 or P | | Paper No(s 5) Notice of Ir | Summary (PTO-413) s)/Mail Date nformal Patent Application (PTC | - 152) |
| Paper No(s)/Mail Da | ate <u>12/11/03</u> . | | 6) | <u> </u> | |

DETAILED ACTION

Claims 1-23 are pending.

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claims 1, 2, 6-10, and 16-19 are rejected under 35 U.S.C. 102(b) as being anticipated by US# 5,935,737 to Yan.

Yan teaches EUV mask repair using a photoresist. During the fabrication of a photolithography mask, double defect-absorbing layers are incorporated to ensure the final mask structure is free of defects. The process begins with a resonant reflector substrate. First and second defect-absorbing layers cover the substrate. The first and second defect-absorbing layers are selected to be repairable if defects form, as well as can be etched selectively relative to each other as well as to the underlying substrate. The first defect-absorbing layer is coated with photoresist. The photoresist is patterned using photolithography. Next, the photoresist pattern is transferred to the first defect-absorbing layer through plasma etching. Any defects arising from the etching step are repaired. Next, the pattern formed in the first defect-absorbing layer is transferred to the second defect-absorbing layer, using the first defect-absorbing layer as a mask. Any defects arising from the etching step are repaired. Next, an absorber layer is deposited into the etched open areas of the first and second defect-absorbing layers. The

Art Unit: 1756

absorber layer is selected to be substantially absorptive to the wavelength of light to be used on the photolithography mask. The absorber layer is planarized, and then remaining defect-absorbing layers are removed. The remaining mask structure consists of the substrate with a patterned absorber layer.

Allowable Subject Matter

- 3. Claims 11-15 and 22-23 allowed.
- 4. Claims 3-5 and 20-21 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 5. The prior art does not teach or suggest the method limitations along with the fluorescent material.

Conclusion

6. Any inquiry concerning this communication or earlier communications from the Examiner should be directed to Saleha Mohamedulla whose telephone number is (571) 272-1387. The Examiner can normally be reached Monday-Friday, from 8:00 AM to 4:30 PM. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

Art Unit: 1756

applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Saleha R. Molfamedulla

Patent Examiner

Technology Center 1700

June 21, 2005